

IN THE UNITED STATES PATENT OFFICE

Patent of : Gonsalves, et al.  
Patent No. : 7,008,749  
Issue Date : March 7, 2006  
Title : High Resolution Resists For Next Generation  
Lithographies

Commissioner for Patents  
P.O. Box 1450  
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TRANSMITTAL

Sir:

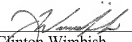
Transmitted herewith are copies of the following documents for filing in the above-identified patent:

1. Revocation of Power of Attorney with a New Power of Attorney and Change of Correspondence Address; and
2. Statement Under 37 CFR 3.73(b).

The Commissioner is hereby authorized to charge any additional fees required by this action, or credit any overpayment, to Deposit Account Number 50-2190.

Respectfully submitted,

By:

  
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2/7/11

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I hereby certify that this document is being electronically filed with the United States Patent and Trademark Office via EFS-Web, on February 7, 2011

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